## YAMAP0800US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Stewart E. HOOPER et al.

Art Unit:

1765

Serial No.: 10/079,269

Examiner: Robert M. Kunemund

Filed: February 19, 2002

METHOD OF GROWING A SEMICONDUCTOR MULTI-LAYER STRUCTURE For:

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450

Alexand	Iria, VA	22313-1450
Sir:		
s direct PTO-14 previous	ed to the 49. A castly cited	nt to 37 C.F.R. 1.97 and 1.98, and in compliance with 37 C.F.R. 1.56, the Office's attention e patents, pending applications, publications and other information listed on the attached opy of each listed document is enclosed except for: (a) pending applications or (b) those or submitted to the Office in the following application(s) upon which this application relies ng date under 35 U.S.C. 120:
	Serial N Filing D	
PTO-14 treated	49, App accordin	document, publication or other information for which a date is not given on the attached licant(s) believe(s) the same may qualify as "prior" art to this application and should be adjusted and should be apply, although Applicant(s) reserve(s) the right to contest the prior art status of any ication or information, should issue arise.
2. translati of the re	ion acco	ing each listed document that is not in the English language, an English-language impanies this Statement as indicated on the attached PTO-1449 or a concise explanation of the document is set forth in the following document(s):
	(a)	Copy of each English language version of a search report indicating the degree of relevance found by the foreign office of each document being submitted from the search report.
	(b)	Attachment entitled "Concise Explanation of Relevance of Non-English Language Documents".
3.	Pursua	nt to 37 C.F.R. 1.97(b) this Statement is being filed (one must be checked):
	(a) <u>X</u>	Within 3 months of the filing date, date of entry into the National Stage, or filing date of RCE.
	(b)	Before the mailing date of a first Office Action on the merits. If this Statement is not filed before the mailing date of a first Office Action on the merits, the required certification is given below or, in the absence thereof, the Office is authorized to charge the required fee

set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988 for consid	deration of	this
Statement.		

- (c) \_\_\_\_ Before the mailing date of a first Office Action on the merits after a first or second submission after final rejection under 37 C.F.R. 1.129(a).
- (d) \_\_\_\_ After the period set forth in 37 C.F.R. 1.97(b) but before the mailing date of either a final action or a notice of allowance.
  - (1) \_\_\_ The required certification is given below, or
  - (2) \_\_\_ Enclosed is a check covering the fee set forth in 37 C.F.R. 1.17(p) for consideration of this Statement, or
  - (3) \_\_\_ Charge the fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988
- (e) \_\_\_\_ After the mailing date of either a final action or a notice of allowance, but before payment of the issue fee. Petition hereby is made for consideration of this Statement and the required certification is indicated below.
  - (1) \_\_\_ Enclosed is a check covering the fee set forth in 37 C.F.R. 1.17(p), or
  - (2) \_\_\_ Charge the fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988.
- 4. Certification (if applicable)
  - (a) \_\_\_ The undersigned hereby certifies that each item of information contained in this Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Statement.
  - (b) \_\_\_\_ The undersigned hereby certifies that no item of information contained in this Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the undersigned's knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. 1.56(c) more than 3 months prior to the filling of this Statement.
- 5. The Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 18-0988.

Respectfully Submitted,

RENNER, OTTO, BOISSELLE & SKLAR, LLP

Mark D. Saralino, Reg. No. 34,243

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Examiner Initial	Document Number	Dale	Name	Class	Sub- class	Filing Date if Appropriate
	5,602,418	2/11/97	Imai et al.			
	5,998,810	12/7/99	Hatano et al.			

FOREIGN PATENT DOCUMENTS

Examiner	Document Number	Date	Country	Clasa	Sub-	Translation	
Initial					dass	Yes	No

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
	Herzog, W.D. et al., <i>Photoluminescence Microscopy of InGaN Quantum Wells</i> , Applied Physics Letters, American Institute of Physics, Vol. 70, No. 11, March 17, 1997, Pages 1333-1335.
	European Search Report for corresponding EP App. No. 02251250.3, dated August 13, 2004.

EXAMINER	DATE CONSIDERED				

EXAMINER:

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution. C:\GEN\YAMA\YAMAP800\yamap800.ids.wpd (IDS1449.FRM) (2/97)